

In re: Gi-Jung Kim et al.  
Serial No. 10/601,475  
Filed: June 23, 2003  
Page 2

In the Title:

Please amend the title to read as follows:

**SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES  
THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING PARTICULATE  
CONTAMINATION AND METHODS OF FORMING SAME**